## AMENDMENTS TO THE CLAIMS

This listing of claims will replace all prior versions and listings of claims in the application:

## LISTING OF CLAIMS:

Claims 1-6 (canceled).

7. (previously presented): A method of constructing a thick film electroluminescent device including the steps of:

placing an insulating layer on an electrode layer;

placing a light emitting layer having phosphor particles and a binder matrix onto the insulating layer;

placing a transparent electrode layer onto the light emitting layer;

causing the phosphor particles from the light emitting layer to protrude into the insulating layer and the transparent electrode layer.

8. (previously presented): The method of claim 7 wherein a mechanism causing the phosphor to protrude from the light emitting layer into the insulating layer is by chemical softening of the insulating layer.

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9. (previously presented): The method of claim 7 wherein the phosphor particles are caused to protrude from the light emitting layer into the insulating layer by heating the binder in the insulating layer above its softening point.

- 10. (previously presented): The method of claim 7 wherein the insulating layer contains a dielectric material.
- 11. (previously presented): The method of claim 7 wherein the dielectric material is Barium Titanate.
- 12. (previously presented): The method of claim 7 wherein the solvent used in the light emitting layer is a solvent for the insulating layer.
- 13. (previously presented): The method of claim 7 wherein the amount of binder to phosphor particles is from approximately 25% binder:75% phosphor particle by dry weight, to approximately 5% binder to 95% phosphor by dry weight.
- 14. (currently amended): A method of constructing a thick film electroluminescent device comprising the steps:

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applying an insulating layer to an electrode layer;

providing a light emitting layer including phosphor particles in a binder matrix, the proportion of phosphor particles in the binder matrix being sufficient such that when solidified, a proportion of the phosphor particles-cause causes protrusions in a top surface and a bottom surface of the light emitting layer;

applying the light emitting layer to the insulating layer; and

applying a second electrode layer;

wherein the insulating layer is heated above its softening temperature to cause the phosphor particles to move into the insulating layer.

15. (original): The method of claim 14 wherein the light emitting layer has a binder to phosphor ratio such that when dried, the phosphor particles protrude from the light emitting layer.

16. (previously presented): The method of claim 14 wherein the amount of binder to phosphor particles is from approximately 25% binder:75% phosphor particle by dry weight, to approximately 5% binder to 95% phosphor by dry weight.

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17. (currently amended): A method of constructing a thick film electroluminescent device comprising the steps:

applying an insulating layer to an electrode layer;

providing a light emitting layer including phosphor particles in a binder matrix, the proportion of phosphor particles in the binder matrix being sufficient such that when solidified, a proportion of the phosphor particles—cause causes protrusions in a top surface and a bottom surface of the light emitting layer;

applying the light emitting layer to the insulating layer; and

heating the insulating layer above its softening temperature to cause the phosphor particles to move into the insulating layer;

then applying a second electrode layer.